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00684.001674.5

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MASAAKI SUZUKI) : Examiner: A. Markoff
Appln. No.: 10/629,636) : Group Art Unit: 1746
Filed: July 30, 2003) :
For: APPARATUS FOR WASHING)
GLASS SUBSTRATES AND)
PROCESS OF PRODUCING A)
LIQUID CRYSTAL DEVICE (AS)
AMENDED)) : October 15, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Sir:

Applicant is in receipt of an Official Filing Receipt in the above-identified application. However, the inventor's address is incorrect. It is requested that "Ohta-ku, JAPAN" be corrected to read --Yokohama-shi, JAPAN--, as shown on the attached copy of the Filing Receipt.

Applicants respectfully request that a corrected Official Filing Receipt be issued listing the inventor's correct address.

Any fees necessitated by this Request should be charged to Deposit Account
06-1205.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



Mark A. Williamson
Attorney for Applicant
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DC_MAIN 181140v1



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Page 1 of 2

APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/629,636	07/30/2003	1746	750	00684.001674.5	2	10	2

HC

CONFIRMATION NO. 9145

5514
FITZPATRICK CELLA HARPER & SCINTO
30 ROCKEFELLER PLAZA
NEW YORK, NY 10112

FILING RECEIPT



OC000000011875614

Original

Date Mailed: 02/11/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s) *Yokohama-shi*
Masaaki Suzuki, ~~Obita-ku~~, JAPAN;

Assignment For Published Patent Application
CANON KABUSHIKI KAISHA, TOKYO, JAPAN;

Domestic Priority data as claimed by applicant

This application is a DIV of 09/695,925 10/26/2000 PAT 6,651,680
and is a DIV of 08/743,375 11/04/1996 PAT 6,217,665
and is a CON of 08/013,314 02/04/1993 ABN

Foreign Applications
JAPAN 055985/1992 02/07/1992

If Required, Foreign Filing License Granted: 02/10/2004

Projected Publication Date: 05/20/2004

Non-Publication Request: No

Early Publication Request: No

Title

Apparatus for washing glass substrates and process for producing a liquid crystal device

Preliminary Class

134

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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